

L Number	Hits	Search Text	DB	Time stamp
1	47	(capacitor near (upper top) near electrode) near5 (spacer sidewall)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:35
2	23	(capacitor near (upper top) near electrode) near5 spacer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:46
3	6	capacitor near (upper top) near electrode near spacer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:48
4	1	spacer near capacitor near (upper top) near electrode	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:49
5	6	capacitor with ((upper top) near electrode near spacer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:52
6	24	capacitor\$1 and ((upper top) near electrode near spacer\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:53
7	5	("6011284"   "6144060"   "6201726"   "6242299"   "6396092").PN.	USPAT	2004/06/17 09:55
8	24	("4145803"   "4481283"   "4890191"   "5037773"   "5053917"   "5099305"   "5138411"   "5182232"   "5187638"   "5227855"   "5241201"   "5278091"   "5293510"   "5349494"   "5366920"   "5369296"   "5418180"   "5429972"   "5443688"   "5444013"   "5495117"   "5555486"   "5595928"   "5612082").PN.	USPAT	2004/06/17 09:59
9	36	("4145803"   "4481283"   "4890191"   "5037773"   "5053917"   "5099305"   "5138411"   "5182232"   "5187638"   "5217914"   "5223448"   "5227855"   "5241201"   "5278091"   "5293510"   "5349494"   "5366920"   "5369296"   "5418150"   "5418180"   "5429972"   "5443688"   "5444013"   "5495117"   "5555486"   "5595928"   "5612082"   "5696017"   "5741722"   "5793076"   "5940676"   "6037206"   "6066528"   "6077737"   "6080621"   "6083788").PN.	USPAT	2004/06/17 10:04

L Number	Hits	Search Text	DB	Time stamp
1	2	("6043526").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 16:20
2	160	etch\$ with (gas\$2 near5 (CHF3 CF4 Ar N2) near5 ((insulat\$3 dielectric) near (layer film)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:39
3	27	(etch\$ with (gas\$2 near5 (CHF3 CF4 Ar N2) near5 ((insulat\$3 dielectric) near (layer film)))) and (capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
6	19	stack\$3 near2 (conduct\$3 adhesive) near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 17:57
7	2413	(conduct\$3 adhesive) near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
8	0	(conduct\$3 adhesive) near2 (before near stack\$3) near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 17:58
9	8	(conduct\$3 adhesive) near2 before near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 17:59
10	1387	((conduct\$3 adhesive) near2 ((lower bottom) near electrode)) and (capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
11	117	adhesive near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
12	73	(adhesive near2 ((lower bottom) near electrode)) and (capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:02
13	27	etch\$ with (gas\$2 near5 (O2 oxygen CHF3 CF4 Ar N2) near5 ((top upper) near electrode))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:41
14	26	etch\$ with (gas\$2 near5 (O2 oxygen Cl2 BC13 Ar HBr) near5 ((top upper) near electrode))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:41